Supplementary Information for:

## High-efficiency Graphene/Si Nanoarray Schottky Junction Solar Cells via Surface Modification and Graphene Doping

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**Fig. S1** (a) Plots of sheet resistance as a function of layer number of the FLG film before and after  $HNO_3$  doping. (b) Transmittance of FLG film with varied layer number.



**Fig. S2** (a) *I-V* characteristics of the 4-layer FLG/CH<sub>3</sub>-SiNH array and 4-layer FLG/CH<sub>3</sub>(Pt)-SiNH array in dark. (b) *I-V* characteristics 4-layer FLG/CH<sub>3</sub>-SiNW array and 4-layer FLG/CH<sub>3</sub>(Pt)-SiNW array in dark.



**Fig. S3** EDS analysis on the P3HT coated SiNW array. The strong C signals observed from both top and side surfaces indicate the uniform coating of P3HT layer on the SiNW array.



**Fig. S4** EDS analysis on the P3HT coated SiNH array. The strong C signals observed from both top surface and side walls indicate the uniform coating of P3HT layer on the SiNH array.



**Fig. S5** (a) *I-V* characteristics of the 4-layer FLG/CH<sub>3</sub>(Pt)-SiNW array with and without P3HT electron blocking layer in dark. (b) *I-V* characteristics of 4-layer FLG/CH<sub>3</sub>-SiNH array with and without P3HT electron blocking layer in dark.



**Fig. S6** Photovoltaic characteristics of  $CH_3(Pt)$ -SiNW array/P3HT (10 nm) and  $CH_3$ -SiNH array/P3HT (10 nm) hybrid heterojunction solar cells with 13 nm Au as anode electrodes. The corresponding PCEs are 5.53% and 7.14%, respectively.



**Fig. S7** Photovoltaic characteristics of 4-layer  $FLG/CH_3$ -planar Si, 4-layer  $FLG/CH_3(Pt)$ -planar Si and 4-layer  $FLG/P3HT/CH_3$ -planar Si after HNO<sub>3</sub> doping. The corresponding PCEs are 2.96%, 1.07% and 5.18%, respectively.